



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Hidemasa KAI**

Group Art Unit: **1763**

Application Number: **10/626,675**

Examiner: **Ram N. Kackar**

Filed: **July 25, 2003**

Confirmation Number: **1831**

For: **EPITAXIAL WAFER PRODUCTION APPARATUS AND  
SUSCEPTOR STRUCTURE**

Attorney Docket Number: **030901**

Customer Number: **38834**

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

October 6, 2006

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated May 8, 2006 for two month(s) from August 8, 2006 to October 8, 2006.

Attached please find a check in the amount of \$450.00 for the cost of the extension.

If any additional fees are due in connection with this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

**WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP**

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DAA/rf

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